AMENDMENT TRANSMITTAL LETTER

Docket No. M4065.0018/P018-A

Application No.	Filing Date	Examiner	Art Unit	
09/507,465	February 22, 2000	M. Anderson	1765	
applicant(s): Rodney C. Lang	ley, et al.			

Invention: METHOD AND APPARATUS FOR PLASMA ETCHING A WAFER

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TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

		CLAIM	S AS AMENI	DED	
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	·
Total Claims	7	- 20 =		x	0.00
Independent Claims	2	- 3 =		х	0.00
Multiple Depen	dent Claims (ch	eck if applicabl	ie)		
Other fee (plea	se specify):				
TOTAL ADDIT	0.00				
x Large Entity	/			Small Ent	ity
x No addition	al fee is require	d for this ame	ndment.		
	rge Deposit Acc			n the amount of \$	
A check in t	he amount of \$		_ to cover	the filing fee is e	nclosed.
Payment by	credit card. F	orm PTO-2038	is attached.		
	r is hereby auth d below. A dup			Deposit Account enclosed.	No. <u>04-1073</u>
x Credit a	any overpayme	at.			
x Charge	any additional fil	ing or application	on processing	fees required unde	er 37 CFR 1.16 and 1.17.
		>	aan no	Dated:	October 8, 2003
Thomas J. D'A					
Attornev Rea.	No.: 28,371				

Attorney Reg. No.: 28,371

DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 828-2232